



LIST OF PUBLICATIONS  
CITED BY APPLICANT

Atty Docket No.  
0553-0401

Serial No.  
10/807,692

Applicant  
Yoshifumi TANADA

Filing Date  
March 24, 2004

Group  
2819

U.S. PATENT DOCUMENTS

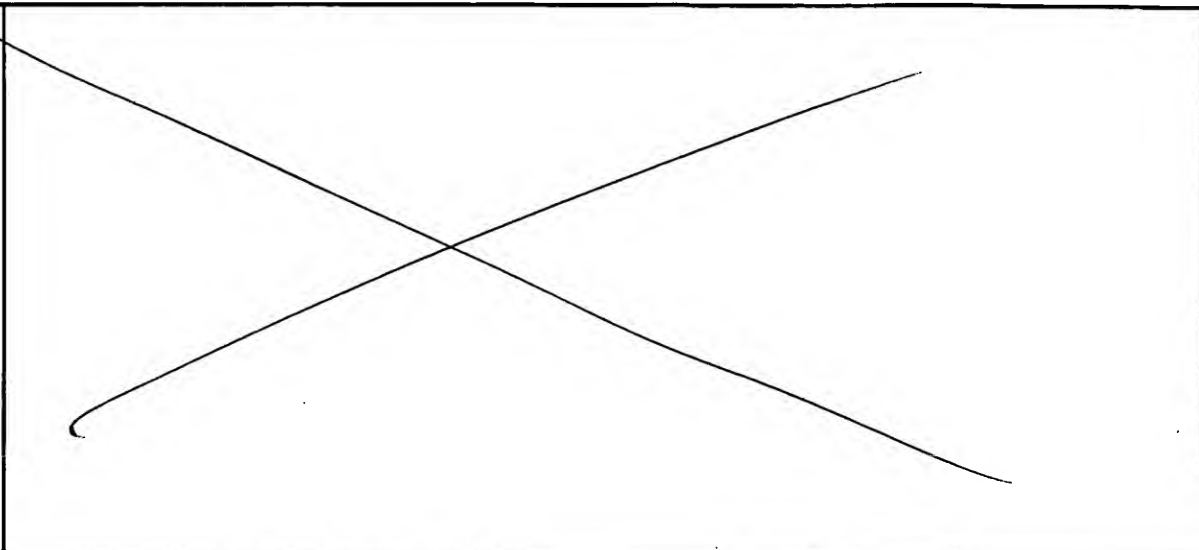
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
<i>tan</i>          <i>tan</i>	US 2001/ 0035526 A1	11/01/01	Yamazaki et al	257	57	04/24/01
	US 2001/ 0040565 A1	11/15/01	Koyama	345	204	05/11/01
	US 2002/ 0130675 A1	09/19/02	Hiroki	324	750	03/18/02
	US 2002/ 0132383 A1	09/19/02	Hiroki et al	438	17	03/18/02
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	6,850,080 B2	02/01/05	Hiroki	324	750	03/18/02
	US 2005/ 0212044 A1	09/29/05	Hiroki	257	347	01/21/05

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	APPLICANT	English Abstract	English Trans.	FILING DATE
<i>tan</i>	JP 2002- 014337	01/18/02	Semiconductor Energy Lab Co. Ltd	X		04/26/01
<i>tan</i>	JP 2002- 032035	01/31/02	Semiconductor Energy Lab Co. Ltd	X		05/10/01
<i>tan</i>	JP 2002- 350513	12/04/02	Semiconductor Energy Lab Co. Ltd	X		03/12/02
<i>tan</i>	JP 2003- 031814	01/31/03	Semiconductor Energy Lab Co. Ltd	X		03/19/02

**OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS**

(Include name of author (in CAPITAL LETTERS), title of article or item (book, magazine, journal, serial, symposium, catalog, etc.) date, pages(s), volume-issue number(s), publisher, city and/or country where published).

	
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EXAMINER:

*W. L. H.*

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\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.